

SLOVENSKI STANDARD SIST ISO 13565-1:2001

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Geometrical Product Specifications (GPS) -- Surface texture: Profile method; Surfaces having stratified functional properties -- Part 1: Filtering and general measurement conditions

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Spécification géométrique des produits (GBS) 555 État de surface: Méthode du profil; surfaces ayant des propriétés fonctionnelles différentes suivant les niveaux -- Partie 1: Filtrage et conditions générales de mesurage iso-13565-1-2001

Ta slovenski standard je istoveten z: ISO 13565-1:1996

ICS:

17.040.20 Lastnosti površin

Properties of surfaces

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INTERNATIONAL STANDARD

ISO 13565-1

First edition 1996-12-01

Geometrical Product Specifications (GPS) — Surface texture: Profile method; Surfaces having stratified functional

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Filtering and general measurement conditions

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Spécification géométrique des produits (GPS) — État de surface: Méthode du profil; surfaces ayant des propriétés fonctionnelles différentes suivant les niveaux —

Partie 1: Filtrage et conditions générales de mesurage



Reference number ISO 13565:1996(E)

Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

Draft International Standards adopted by the technical committees are circulated to the member bodies for voting. Publication as an International Standard requires approval by at least 75 % of the member bodies casting a vote.

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International Standard ISO 13565-1 was prepared jointly by Technical Committees ISO/TC 57, Metrology and properties of Surfaces, Subcommittee SC 1, Geometrical parameters — Instruments and procedures for measurement of surface roughness and waviness, ISO/TC 3,0Limits and fits, and ISO/TC 10, Technical drawings, product definition and related documentation, Subcommittee SC 5, Dimensioning and tolerancing5-1-2001

ISO 13565 consists of the following parts, under the general title *Geometrical product specifications (GPS)* — *Surface texture: Profile method; Surfaces having stratified functional properties:*

- Part 1: Filtering and general measurement conditions
- Part 2: Height characterization using the linear material ratio curve
- Part 3: Height characterization using the material probability curve

Annexes A and B of this part of ISO 13565 are for information only.

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International Organization for Standardization

Case Postale 56 • CH-1211 Genève 20 • Switzerland

Printed in Switzerland

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Introduction

This part of ISO 13565 is a Geometrical Product Specification (GPS) standard and is to be regarded as a *General GPS standard* (see ISO/TR 14638). It influences chain links 2 and 3 of the chain of standards for roughness profile.

For more detailed information of the relation of this standard to other standards and the GPS matrix model, see annex A.

The roughness profile generated using the filter defined in ISO 11562 suffers some undesirable distortions, when the measured surface consists of relatively deep valleys beneath a more finely finished plateau with minimal waviness. This type of surface is very common, for example in cylinder liners for internal combustion engines.

This part of ISO 13565 provides a method of greatly reducing these distortions, thus enabling the parameters defined in ISO 13565-2 and ISO 13565-3 to be used for evaluating the above mentioned type of surface with minimal influence from these distortions.

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Geometrical Product Specification (GPS) — Surface texture: Profile method; Surfaces having stratified functional properties —

Part 1:

Filtering and general measurement conditions

1 Scope

This part of ISO 13565 describes a filtering method for use with surfaces that have deep valleys below a more finely finished plateau with a relatively small amount of vaviness. The reference line resulting from filtering according to ISO 11562 for such surfaces is undesirably influenced by the presence of the valleys. The filtering approach described in this standard suppresses the valley influence on the reference line such that a more satisfactory reference line is generated.

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2 Normative references

The following standards contain provisions which, through reference in this text, constitute provisions of this part of ISO 13565. At the time of publication, the editions indicated were valid. All standards are subject to revision, and parties to agreements based on this part of ISO 13565 are encouraged to investigate the possibility of applying the most recent editions of the standards indicated below. Members of IEC and ISO maintain registers of currently valid International Standards.

ISO 3274:1996, Geometrical Product Specifications (GPS) — Surface texture: Profile method — Nominal characteristics of contact (stylus) instruments.

ISO 4287:1996, Geometrical Product Specifications (GPS) — Surface texture: Profile method — Terms, definitions and surface texture parameters.

ISO 11562:1996, Geometrical Product Specifications (GPS) — Surface texture: Profile method — Metrological characteristics of phase correct filters.

3 Definitions

For the purposes of this part of ISO 13565, the definitions given in ISO 3274 and ISO 4287 apply.

4 Reference guide

To measure profiles in accordance with this part of ISO 13565, a measuring system which incorporates an external reference is recommended. In case of arbitration the use of such a system is obligatory.

5 Traversing direction

The traversing direction shall be perpendicular to the direction of lay unless otherwise indicated.

6 Filtering process to determine the roughness profile

The filtering process is carried out in several stages giving the modified profiles, sections of which are illustrated in figure 1a) to d).

The first mean line is determined by a preliminary filtering of the primary profile with the phase correct filter in accordance with ISO 11562 using a cut-off wavelength λc in accordance with clause 7 and corresponding measuring conditions in accordance with table 1 of ISO 3274:1996. All valley portions which lie below this mean line (shown hatched in figure 1a) are removed. In these places the primary profile is replaced by the curve of the mean line.

The same filter is used again on this profile with the valleys suppressed. The second mean line thus obtained (see figure 1b) is the reference line relative to which the assessment of profile parameters is performed. This reference line is tranferred to the original primary profile (see figure 1c) and the roughness profile according to this part of ISO 13565 is obtained from the difference between the primary profile and the reference line (see figure 1d).

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7 Selection of the cut-off wavelength Re and the evaluation length in

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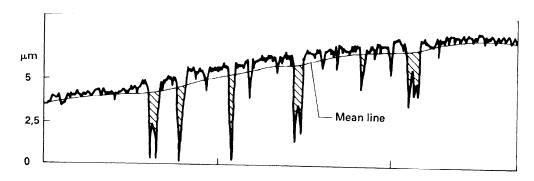
The measurements shall preferably be carried out using a cut-off wavelength of $\lambda c = 0.8$ mm. In justified exceptional cases, $\lambda c = 2.5$ mm may be selected and this shall be stated in the specification and test results.

Table 1 provides the relationship between cut-off wavelength λc and the evaluation length ln

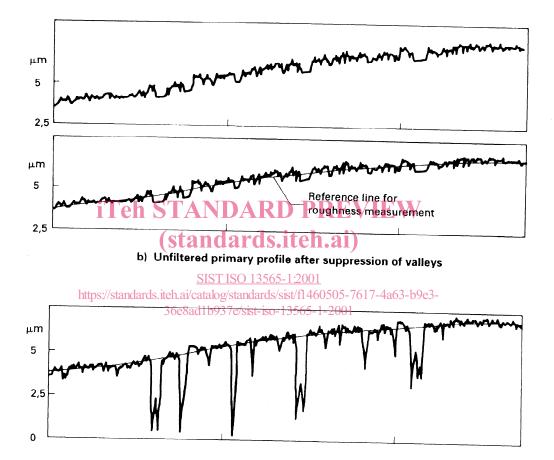
Table 1 — Relationship between the cut-off wavelength λc and the evaluation length ln

Dimensions in millimetres

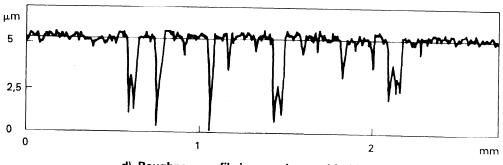
λς	ln
0,8	4
2,5	12,5



a) Unfiltered primary profile (valleys shown hatched)



c) Position of the reference line in the primary profile



d) Roughness profile in accordance with this standard

Figure 1 — Filtering process